



**HAL**  
open science

## Sub-wavelength energy concentration with electrically generated mid-infrared surface plasmons

Adel Bousseksou, Arthur Babuty, Jean-Philippe Tetienne, Ioana Cristina Moldovan Doyen, Rémy Braive, Grégoire Beaudoin, Isabelle Sagnes, Yannick de Wilde, Raffaele Colombelli

► **To cite this version:**

Adel Bousseksou, Arthur Babuty, Jean-Philippe Tetienne, Ioana Cristina Moldovan Doyen, Rémy Braive, et al.. Sub-wavelength energy concentration with electrically generated mid-infrared surface plasmons. *Optics Express*, 2012, 20 (13), pp.13738. hal-00706889

**HAL Id: hal-00706889**

**<https://hal.science/hal-00706889v1>**

Submitted on 11 Jun 2012

**HAL** is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.

# Sub-wavelength energy concentration with electrically generated mid-infrared surface plasmons

A. Bousseksou,<sup>1,\*</sup> A. Babuty,<sup>2</sup> J-P. Tetienne,<sup>1</sup> I. Moldovan-Doyen,<sup>2</sup>  
R. Braive,<sup>3</sup> G. Beaudoin,<sup>3</sup> I. Sagnes,<sup>3</sup>  
Y. De Wilde,<sup>2,4</sup> and R. Colombelli<sup>1,5</sup>

<sup>1</sup> *Institut d'Electronique Fondamentale, Univ. Paris Sud, UMR8622 CNRS, 91405 Orsay, France*

<sup>2</sup> *Institut Langevin, ESPCI ParisTech, CNRS UMR 7587, 75005 Paris, France*

<sup>3</sup> *Laboratoire de Photonique et Nanostructures, CNRS UPR20, 91460 Marcoussis, France*

<sup>4</sup> [yannick.dewilde@espci.fr](mailto:yannick.dewilde@espci.fr)

<sup>5</sup> [raffaele.colombelli@u-psud.fr](mailto:raffaele.colombelli@u-psud.fr)

[\\*adel.bousseksou@u-psud.fr](mailto:adel.bousseksou@u-psud.fr)

**Abstract:** While freely propagating photons cannot be focused below their diffraction limit, surface-plasmon polaritons follow the metallic surface to which they are bound, and can lead to extremely sub-wavelength energy volumes. These properties are lost at long mid-infrared and THz wavelengths where metals behave as quasi-perfect conductors, but can in principle be recovered by artificially tailoring the surface-plasmon dispersion. We demonstrate - in the important mid-infrared range of the electromagnetic spectrum - the generation onto a semiconductor chip of plasmonic excitations which can travel along long distances, on bent paths, to be finally focused into a sub-wavelength volume. The demonstration of these advanced functionalities is supported by full near-field characterizations of the electromagnetic field distribution on the surface of the active plasmonic device.

© 2012 Optical Society of America

**OCIS codes:** (140.5960) Semiconductor lasers; (230.5750) Resonators; (240.6680) Surface plasmons.

---

## References and links

1. J.B. Pendry, L. Martin-Moreno, and M. Garcia-Vidal, "Mimicking surface plasmons with structured surfaces," *Science* **305**, 847–848 (2004).
2. F. J. Garcia de Abajo and J. J. Saenz, "Electromagnetic surface modes in structured perfect-conductor surfaces," *Phys. Rev. Lett.* **95**, 233901 (2005).
3. D. Martin-Cano, M. L. Nesterov, A. I. Fernandez-Dominguez, F. J. Garcia-Vidal, L. Martin-Moreno, and E. Moreno, "Domino plasmons for subwavelengthterahertz circuitry," *Opt. Express* **18**, 754–764 (2010).
4. N. Janunts, K. Baghdasaryan, K. Nerkararyan, and B. Hecht, "Excitation and superfocusing of surface plasmon polaritons on a silver-coated optical fiber tip," *Opt. Commun.* **253**, 118–124 (2005).
5. V. S. Volkov, J. Gosciniak, S. I. Bozhevolnyi, S. G. Rodrigo, L. Martin-Moreno, and F. J. Garcia-Vidal, "Plasmonic candle: towards efficient nanofocusing with channel plasmon polaritons," *New J. Phys.* **11**, 113043 (2009).
6. E. Moreno, S. Rodrigo, S. Bozhevolnyi, L. Martin-Moreno, and F. Garcia-Vidal, "Guiding and focusing of electromagnetic fields with wedge plasmon polaritons," *Phys. Rev. Lett.* **100**, 023901 (2008).
7. D. K. Gramotnev and S. I. Bozhevolnyi, "Plasmonics beyond the diffraction limit," *Nat. Photonics* **4**, 83–91 (2010).

8. M. I. Stockman, "Nanofocusing of optical energy in tapered plasmonic waveguides," *Phys. Rev. Lett.* **93**, 137404 (2004).
9. R. J. Walters, R. V. A. van Loon, I. Brunets, J. Schmitz, and A. Polman, "A silicon-based electrical source of surface plasmon polaritons," *Nat. Mater.* **9**, 21–25 (2010).
10. J. A. Schuller, E. S. Barnard, W. Cai, Y. C. Jun, J. S. White, and M. L. Brongersma, "Plasmonics for extreme light concentration and manipulation," *Nat. Mater.* **9**, 193–204 (2010).
11. A. P. Hibbins, B. R. Evans, and J. R. Sambles, "Experimental verification of designer surface plasmons," *Science* **308**, 670–672 (2005).
12. C. R. Williams, S. R. Andrews, S. Maier, A. I. Fernandez-Dominguez, L. Martin-Moreno, and F. J. Garcia-Vidal, "Highly confined guiding of terahertz surface plasmon polaritons on structured metal surfaces," *Nat. Photonics* **2**, 175–179 (2008).
13. E. M. G. Brock, E. Hendry, and A. P. Hibbins, "Subwavelength lateral confinement of microwave surface waves," *Appl. Phys. Lett.* **99**, 051108 (2011).
14. W. Zhao, O. M. Eldaiki, R. Yang, and Z. Lu, "Deep subwavelength waveguiding and focusing based on designer surface plasmons," *Opt. Express* **18**, 21498–21503 (2010).
15. N. Yu, Q. J. Wang, M. A. Kats, J. A. Fan, S. P. Khanna, L. Li, A. G. Davies, E. H. Linfield, and F. Capasso, "Designer spoof surface plasmon structures collimate terahertz laser beams," *Nat. Mater.* **9**, 730–735 (2010).
16. S. C. Kehr, M. Cebula, O. Mieth, T. Hartartling, J. Seidel, S. Grafstrom, L. M. Eng, S. Winnerl, D. Stehr, and M. Helm, "Anisotropy contrast in phonon-enhanced apertureless near-field microscopy using a free-electron laser," *Phys. Rev. Lett.* **100**, 256403 (2010).
17. S. C. Kehr, Y. M. Liu, L. W. Martin, P. Yu, M. Gajek, S.-Y. Yang, C.-H. Yang, M. T. Wenzel, R. Jacob, H.-G. von Ribbeck, M. Helm, X. Zhang, L. M. Eng, and R. Ramesh, "Near-field examination of perovskite-based superlenses and superlens-enhanced probe-object coupling," *Nat. Commun.* **2**, 249 (2011).
18. H. C. Liu and F. Capasso, Eds. *Intersubband Transitions in Quantum Wells: Physics and Device Applications* (Academic Press, 1999).
19. J.-P. Tetienne, A. Bousseksou, D. Costantini, R. Colombelli, A. Babuty, I. Moldovan-Doyen, Y. De Wilde, C. Sirtori, G. Beaudoin, L. Largeau, O. Mauguin, and I. Sagnes, "Injection of midinfrared surface plasmon polaritons with an integrated device," *Appl. Phys. Lett.* **97**, 211110 (2010).
20. FDTD simulations have been performed with the commercial software package LUMERICAL.
21. Y. De Wilde, F. Formanek, R. Carminati, B. Gralak, P.-A. Lemoine, J.-P. Mulet, K. Joulain, Y. Chen, and J.-J. Greffet, "Thermal radiation scanning tunnelling microscopy," *Nature* **444**, 740–743 (2006).
22. Y. De Wilde, F. Formanek, and L. Aigouy, "Apertureless near-field scanning optical microscope based on a quartz tuning fork," *Rev. Sci. Instrum.* **74**, 3889–3891 (2003).
23. V. Moreau, M. Bahriz, R. Colombelli, P. A. Lemoine, Y. De Wilde, L. R. Wilson, and A. B. Krysa, "Direct imaging of a laser mode via midinfrared near-field microscopy," *Appl. Phys. Lett.* **90**, 201114 (2007).
24. A. Bousseksou, R. Colombelli, A. Babuty, Y. De Wilde, Y. Chassagneux, C. Sirtori, G. Patriarche, G. Beaudoin, and I. Sagnes, "A semiconductor laser device for the generation of surface-plasmons upon electrical injection," *Opt. Express* **17**, 9391–9400 (2009).
25. B. Knoll and F. Keilmann, "Enhanced dielectric contrast in scattering-type scanning near-field optical microscopy," *Opt. Commun.* **182**, 321–328 (2000).
26. A. Cvitkovic, N. Ocelic, and R. Hillenbrand, "Analytical model for quantitative prediction of material contrasts in scattering-type near-field optical microscopy," *Opt. Express* **15**, 8550–8565 (2007).
27. P. M. Krenz, R. L. Olmon, B. A. Lail, M. B. Raschke, and G. D. Boreman, "Near-field measurement of infrared coplanar strip transmission line attenuation and propagation constants," *Opt. Express* **18**, 21678–21686 (2010).
28. D. Dey, J. Kohoutek, R. M. Gelfand, A. Bonakdar, and H. Mohseni, "Composite nano-antenna integrated with quantum cascade laser," *IEEE Photon. Technol. Lett.* **22**, 1580–1582 (2010).
29. M. Schnell, P. Alonso-Gonzalez, L. Arzubiaiga, F. Casanova, L. E. Hueso, A. Chuvilin, and R. Hillenbrand, "Nanofocusing of mid-infrared energy with tapered transmission lines," *Nat. Photonics* **5**, 283–287 (2011).

## 1. Introduction

Guiding, focusing and confining long-wavelength radiation with metals requires artificially tailoring the dispersion of surface-plasmon polaritons (SPPs), which at mid-infrared (mid-IR, 10-100 THz) and THz (1-10 THz) frequencies are barely distinguishable from free photons when they propagate on flat metallic surfaces. Such *dispersion engineering* can be achieved with a properly designed sub-wavelength metallic patterning [1–3]: the new, artificial dispersion relation leads to SPPs with larger wavevectors than SPPs on planar surfaces (Fig. 1(a)), and consequently with reduced decay-length in the direction orthogonal to the metal surface. Long infrared SPPs can then be manipulated just as their short-wavelength counterparts. Be-

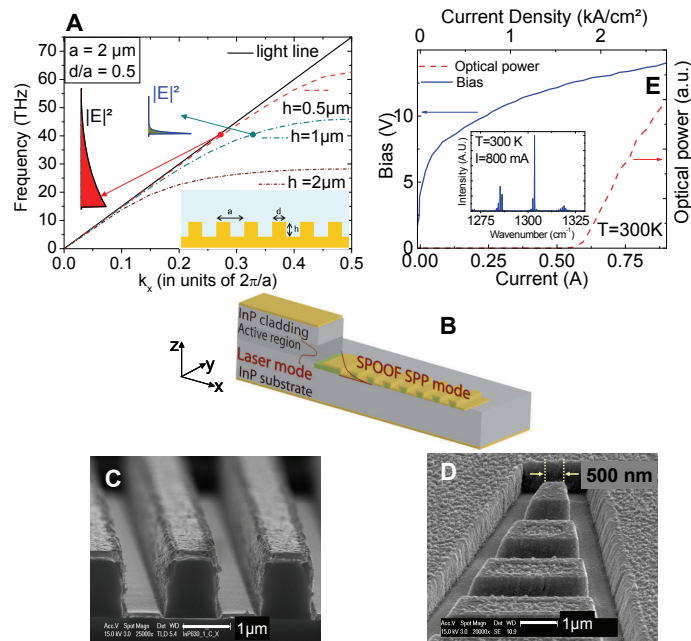


Fig. 1. (a) Dispersion relation of designer's SPPs for a fixed grating period  $a = 2 \mu\text{m}$ ,  $d/a = 0.5$  and various grating depth  $h$ . Bottom inset: schematics of the metal grating and definition of the geometric parameters. Top inset: Effect of the dispersion relation on the confinement: larger wavevectors yield increased field confinements. (b) Schematics of the device and operating principle. (c,d) Scanning electron microscope image of the sub-wavelength metal grating (c, cross section) and of the focusing end of the device (d). (e) Voltage-current (solid blue line) and light-current (dashed red line) characteristics at room-temperature of a 1400- $\mu\text{m}$ -long and 22- $\mu\text{m}$ -wide device. Inset: Typical emission spectrum at RT. The measurements are performed in pulsed mode (50 ns pulses, 84 kHz repetition rate), using a Fourier Transform Infrared Spectrometer equipped with a liquid-nitrogen-cooled HgCdTe detector. The laser threshold current density is  $1.8 \text{ kA/cm}^2$

cause of their spectral location, THz and mid-IR plasmonics promise to lead to a variety of applications in detection and bio-detection [4]. Crucial to this goal, is the availability of an enabling technology which can (i) generate SPPs on demand, at room temperature and with reasonable power, (ii) guide the radiation on a chip, (iii) over distances much larger than the wavelength, and (iv) concentrate the electromagnetic (EM) field within micron-scale-distances of the surface. Such a result will also open the way to the development of active tools for near-field microscopy in a difficult spectral range, where fibers are not available [5]. The goal of this letter is to demonstrate this enabling concept.

At near-infrared wavelengths, functionalities such as guiding and energy focusing, using tips or wedge/channel SPP waveguides have been proposed and demonstrated [6–8]. Semiconductor-based generation is reported in [9], and a complete review can be found in [10]. At longer wavelengths, possibly because of the increased difficulty in generation and detection of SPPs, few experimental demonstrations are present [11–14]. These works have however validated the concept of designer SPPs at microwaves and sub-THz frequencies on passive metal structures [3]. Designer SPPs structures on the highly doped semiconductor facets of THz quantum cascade lasers have also been used to collimate the laser beam output [15]. We demonstrate

here a device, which operates at room temperature, is electrically driven and is able to generate, couple, propagate with sub-wavelength confinement on a chip (over macroscopic distances), and focus mid-IR radiation into a sub-wavelength region. We employ a scattering near-field scanning optical microscope (s-NSOM) to directly elucidate the SPP presence, propagation and characteristics, and demonstrate sub-wavelength confined guiding and focusing effects. Note that we provide s-NSOM measurements as a function of the tip-to-surface distance too. This is rarely seen at long IR wavelengths [16, 17], but it is crucial to prove that the EM field is confined within sub-wavelength proximity of the artificially patterned metallic surface in all three dimensions of space.

## 2. Design and fabrication

Figure 1(a) shows the calculated dispersion relation of designer SPPs propagating along a properly structured gold surface, whose schematics is reported in the inset. At constant frequency, increasing the grooves depth increases the in-plane ( $k_x$ ) wavevector [1–3]. The SPP electric field decay length  $-\delta_z = \frac{1}{\sqrt{k_x^2 - k_0^2}}$  where  $k_0$  is the free-photon wavevector- is also decreased, and the EM field is enhanced close to the interface. Increasing the wavevector increases the propagation (ohmic) losses. The energy attenuation length is  $\frac{1}{\alpha_x} = \frac{1}{2\text{Im}(k_x)}$ .

Given a target frequency of 40 THz (our laser emits at  $\lambda \approx 7.7 \mu\text{m}$ ) a grating with geometrical parameters  $d = 1 \mu\text{m}$ ,  $h = 0.7 \mu\text{m}$  and  $a = 2 \mu\text{m}$  is a good trade-off between confinement ( $\delta_z = 3.08 \mu\text{m}$ ) and loss ( $1/\alpha_x = 115 \mu\text{m}$ ). These are the parameters used for the device presented in this paper, whose scheme is presented in Fig. 1(b). It is based on a mid-IR quantum cascade laser (QCL) emitting at ( $\lambda \approx 7.7 \mu\text{m}$ ), whose details can be found in the Appendix 1.

We exploit the transverse magnetic (TM) polarized emission, a natural feature of QCLs [18], to directly couple the output laser radiation into a SPP mode [19]. The sub-wavelength grating is patterned into a silicon dioxide ( $\text{SiO}_2$ ) carrier layer and it starts in the near-field (1-2  $\mu\text{m}$  distance) of the laser output facet, which corresponds to the end-fire coupling geometry. The top and sides of the patterned  $\text{SiO}_2$  grating are then coated with gold, as shown in Figs. 1(c) and 1(d). This grating can be seen as a practical realization of the recently proposed domino plasmons geometry [3, 13]. The laser output is hence coupled into the SPP modes on the gold/air interface.

## 3. Far-field and near-field analysis

Figure 1(e) presents the optoelectronic characterization of the laser source, as measured at room temperature (300K) as a function of the injected current. The corresponding laser spectrum is shown in the inset of Fig. 1(e).

The grating is designed in a geometry which is meant to focus the SPPs at its end tip, which is located on the opposite end with respect to the laser output facet. The focusing grating is constituted of two main parts (see Fig. 2(b) for the AFM topography). The first section (180- $\mu\text{m}$ -long in the x-direction) has a fixed width (40- $\mu\text{m}$ -wide in the y-direction). It is twice as wide as the laser ridge waveguide, to ensure maximum coupling between the laser and the SPP carrying layer. Using finite difference time domain (FDTD) simulations [20] we estimate a coupling efficiency  $\sim 30\%$ . The second part (80- $\mu\text{m}$ -long in the x-direction) of the focusing grating is a two dimensional funnel: it is 40- $\mu\text{m}$ -wide at the beginning and 500 nm-wide at the tip. Scanning electron microscopy (SEM) images of the focusing grating and of the tip are shown in Figs. 1(c) and 1(d). We have employed a custom-built mid-IR s-NSOM [21,22] to map the near-field on the grating surface. Our previous works on QCLs [23, 24] have demonstrated that s-NSOM is a powerful and robust technique, which yields simultaneously the topography and the near-field signals. Figures 2(a) and 2(b) show a wide two dimensional scan (250  $\mu\text{m} \times 70$

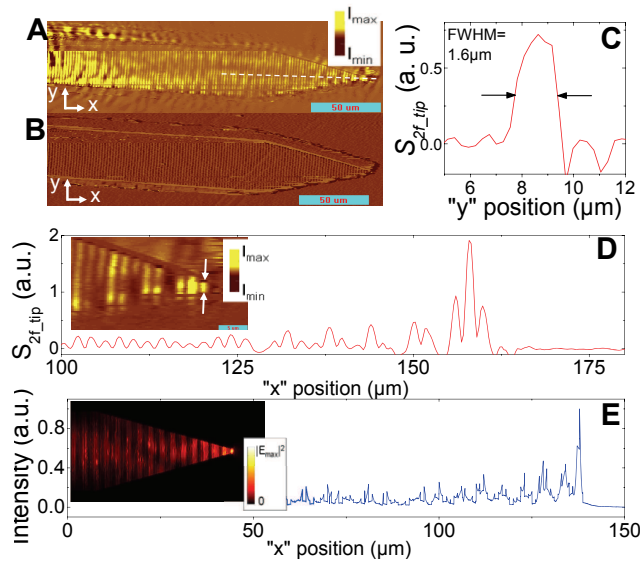


Fig. 2. (a,b) Near-field optical signal demodulated at the second harmonic frequency of the tip,  $S_{2f,tip}$ , and AFM topography of the focusing grating device. The s-NSOM is operated with a tungsten tip oscillating at a frequency  $f_{tip}$  with amplitude 100 nm. (c) 1D cross-section of the near-field signal performed at the funnel end along the y axis, as highlighted by the white dotted arrows in the inset of Fig. 2(d). (d) 1D cross section of the near-field signal performed along the x-axis following approximately the dashed white line in Fig. 1(a). The signal at the funnel-end (right side of the figure) is on average 5 times more intense than on the funnel beginning. Inset: Close-up of the s-NSOM image around the funnel-end of the focusing grating. (e) Finite element 3D calculation of the electric field intensity ( $|E_{norm}|^2$ ) recorded at a distance of  $0.1 \mu\text{m}$  above the sub-wavelength grating. The main figure shows a 1D cross section for comparison with the data in panel d, showing a good qualitative agreement.

$\mu\text{m}$ ) of the sub-wavelength focusing device. The near-field signal (Fig. 2(a)) proves that the EM field follows the metallic waveguide and it is confined onto the sub wavelength grating. Note that the near-field signal is detected here at twice the tip oscillation frequency using a lock-in amplifier, and is therefore denoted as  $S_{2f,tip}$ , in order to suppress any possible contribution from background scattering [25,26]. Its intensity globally decays along the propagation direction (the x-direction) in the initial, constant-width section of the grating. An estimate of the SPP decay length ( $1/\alpha_x$ ) is provided in Appendix 3. We obtain  $60 \mu\text{m}$ , while the theoretical estimate is  $115 \mu\text{m}$ . We attribute the difference to processing imperfections (roughness of the metallization), which reduce the propagation length. This estimate is based on the assumption that the field intensity distribution along z does not change significantly as the grating becomes narrower. This hypothesis is supported by theoretical calculations - reported in [3] - showing that the dispersion relation in a designer's plasmons waveguide is independent of the grating width, even when the latter becomes narrower than the wavelength.

The decay length we *experimentally* measure is 10 times larger than what can be obtained with strip transmission lines [27], thus enabling on-chip mid-IR circuitry. Note: the vertical confinement reported in Refs. [27,29] is tighter, but the confinement achieved here is sufficient for our scope, which is to guide and focus mid-IR radiation into sub-wavelength volumes. A legitimate question is, however, the comparison of the two approaches at equal field confinements. We have theoretically compared the microstrip lines in [27] with a modified design

based on designer's SPPs, featuring an intensity perpendicular confinement of 700 nm. The corresponding calculated propagation length is  $\sim 83 \mu\text{m}$  ( $\sim 10 \times \lambda$ ), while a microstrip line - according to [27] - would yield a value of  $\sim 12 \mu\text{m}$ , i.e. of the order of the wavelength.

In the second, funnel-like section of the grating the trend is reversed: the focusing effect overcomes the losses, a gradual field enhancement along the propagation direction is detected, and a maximum intensity is measured at the funnel tip (Fig. 2(d) and inset). Figures 2(c) and 2(d) show 1D cross sections (y- and x-directions, respectively) of the near-field measurements in Fig. 2(a).

A minimum field enhancement by a factor of 5 at the funnel-end with respect to the averaged field intensity at the funnel beginning, and also a sub-wavelength ( $1.6 \mu\text{m}$ ) measured full width at half maximum ( $\lambda/5$ ) confinement along the y direction at the tip end are demonstrated. The measurements are in good agreement with our FEM (finite element method) simulations, reported in Fig. 2(e) and inset. This is the first demonstration of surface-wave generation, propagation, focusing and sub-wavelength field confinement combined in a single device operating at room temperature and with good performances. Note that these functionalities are spatially separated (our structure is approximately 40 times  $\lambda$  long), since a propagating surface wave is focused. This is in contrast with antenna focusing which leads to higher spatial confinements [28, 29], but requires in general wavelength-sized objects which are entirely immersed in the radiation incoming from free space. Additional functionalities, such as waveguide bends, which are essential for lab-on-chip applications, can be implemented within the same approach, and are described in Appendix 2.

#### 4. Evidence of field-enhancement with designer's surface-plasmons

In the last part of the paper, we present evidence of the increased perpendicular field confinement of the designer's SPPs, a consequence of the artificially engineered dispersion (see Fig. 1(a)). The tip oscillates along z, with an oscillation amplitude of  $\alpha \approx 100 \text{ nm}$  and with an oscillation frequency  $f_{tip} = 32 \text{ kHz}$ . In order to get some insight regarding how far the electromagnetic field extends above the metallic grating, the s-NSOM tip - at a given position on the device surface - is retracted from the  $z = z_0$  position (tip in contact with the grating) to the  $z = z_0 + 10 \mu\text{m}$  position. The s-NSOM signal  $S$  at the optical detector is demodulated with a lock-in amplifier at the laser frequency rate  $f_{laser} = 85 \text{ kHz}$ . The measurement of  $S$  at  $f_{laser}$ , which we call  $S_{f_{laser}}$ , allows one to detect the presence of the electromagnetic field at large distance from the surface when the tip apex is far from its image.

This is not possible when demodulating the s-NSOM signal at  $f_{tip}$  (first or second harmonic) [25, 26]. A simple Taylor expansion of  $S(z + \alpha \cos 2\pi f_{tip} t)$  about z shows that for small  $\alpha$ , the demodulated signal at  $f_{tip}$  (or  $2f_{tip}$ ) is proportional to the first (or second) derivative of  $\sigma|E|^2$  with respect to z. For the devices investigated in the paper, the field  $E$  varies on a scale of several micrometers (metal grating) or of several tens of micrometers (flat metal surface), which is in both cases much larger than  $\alpha$ . Within a few hundreds of nanometers from the sample surface, the variations of  $E$  with respect to  $|z_0 - z|$  on the scale of  $\alpha$  are therefore negligibly small in comparison to the strong variations of  $\sigma$  induced by the image of the tip in the sample surface. To a first approximation, the signal demodulated at  $f_{tip}$  is then proportional to  $|E|^2 \frac{d\sigma}{dz}$ , and the signal demodulated at  $2f_{tip}$  is proportional to  $|E|^2 \frac{d^2\sigma}{dz^2}$ . At larger tip-sample separation,  $\sigma = \sigma_0$  and detection at  $f_{tip}$  or  $2f_{tip}$ , yields to a signal proportional  $\sigma_0 \frac{d|E|^2}{dz}$  or  $\sigma_0 \frac{d^2|E|^2}{dz^2}$ .

Note that  $S_{f_{laser}}$  results from scattering of the electromagnetic field by the entire tip structure, and not only from the tip apex, which only allows one to obtain a qualitative insight regarding the field confinement. We have measured  $S_{f_{laser}}$  versus the tip-sample distance  $|z - z_0|$  at various "x" positions along a line crossing the metallic grating to scan the near-field in the x-z plane.

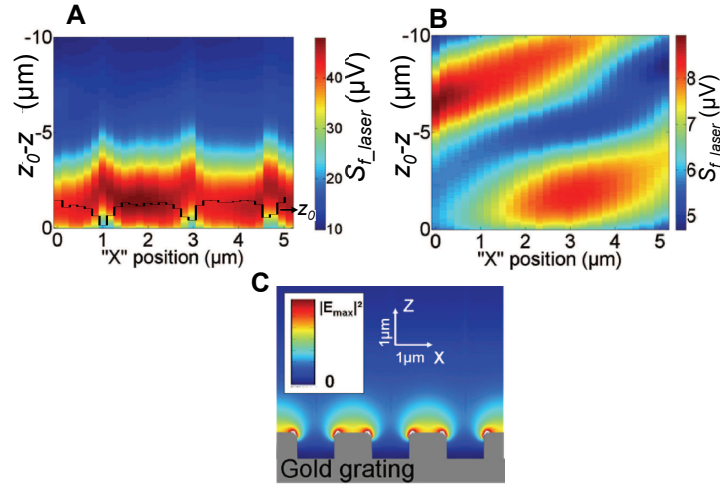


Fig. 3. (a,b) Near-field optical signal demodulated with a lock-in amplifier at the laser modulation frequency,  $S_{f\_laser}$ . The scattered near-field signal is measured as a function of the x-z tip position, while the y position is fixed.  $z_0$  is the absolute z coordinate (measured at each x position) corresponding to the situation where the tip is in contact with the sample surface. Hence,  $|z - z_0|$  is the distance between the tip and the sample surface. The color map intensity is in  $\mu\text{V}$  (micro-Volts) and it corresponds to the lock-in amplifier signal. Panel (a) reports the measurements on the sub-wavelength grating. The solid black line is the simultaneously acquired grating profile obtained by measuring  $z_0$  as a function of x. Panel (b) reports the measurements on a metallic unpatterned section of a reference device. The measurements are performed with the same tip and at identical laser injection currents. (c) Finite-elements numerical simulations of the electric field intensity  $|E_{\text{norm}}|^2$  on the sub-wavelength grating. The geometric and wavelength parameters are in agreement with the measured device shown in Fig. 3(a).

This measurement is possible as little stray photons are present on the device and the majority of the field is evanescent. The result of this scan is shown in Figure 3.

We compared the s-NSOM signal  $S_{f\_laser}$  on the sub-wavelength grating with a reference device where SPPs are injected onto a plain, un-patterned metallic guide at the output facet of an identical QCL, processed simultaneously on the same chip. The same injection current was used on both devices to allow a proper comparison. The measurements (Fig. 3(a)) in the sub-wavelength metal grating show clear field confinement close to the surface. Indeed,  $S_{f\_laser}$  decays over a distance of the order of  $3 \mu\text{m}$ , which indicates that there is no significant field associated to the spoof SPPs beyond this distance from the grating. This behavior agrees qualitatively with the theoretical value of the field intensity decay length which is predicted to be  $\approx 1.5 \mu\text{m}$  (see Fig. 3(c)).

Note that the measurements of  $S_{f\_laser}$  in Fig. 3(a) start in contact with the surface (at  $|z - z_0| = 0$ ), while  $z_0$  shown by the black solid line varies sometimes abruptly with x as it follows the grating profile, which produces apparent discontinuities in the figure. The data prove that little field is present at more than  $3 \mu\text{m}$  from the metallic surface: indeed the designer SPPs are tightly bound to the metallic layer. Furthermore, this measurement excludes the presence of a significant background originating from the laser source, which is also supported by the fact that NSOM images recorded in the xy plane on the sub-wavelength grating at  $f_{tip}$  and  $2f_{tip}$  are essentially identical (data not shown). On the contrary, the reference device yields a signal over the entire range which is accessible with the s-NSOM in the z-direction, as in Fig. 3(b). This is consistent with the poor confinement ( $\delta z / 2 = 27 \mu\text{m}$ ) expected for a SPP on a flat surface



in the mid-IR. The patterned metallic surface induces a (sub-wavelength) field confinement one order of magnitude higher than a flat surface. Note: the absolute value of the s-NSOM signal demodulated at  $f_{laser}$  is much larger on the metal grating than on the unpatterned metallic surface. This is a first indication that the enhanced confinement of the designer's plasmons leads to an enhanced EM field at the metal-air interface. By comparing the magnitude of the near-field signals detected with the same tip at twice its oscillation frequency on the two devices, we estimate that the intensity of the surface EM field of designer SPPs is about one order of magnitude larger than for regular SPPs.

## 5. Conclusions

In conclusion, we have demonstrated the generation, sub-wavelength confined guiding over macroscopic distances and sub-wavelength concentration of mid-IR energy with an electrically-powered and room-temperature operating device. Besides the obvious advantage of being compact, the demonstrated concept opens new vistas for integrated plasmonics at long-IR wavelengths, since it uses propagating waves which are at the same time highly confined. Furthermore, it is possible to couple this architecture with plasmonic antennas, tapered transmission lines, and/or metallic nano-particles.

## Appendix 1: Laser material and device processing

The samples were grown in a vertical-reactor, low-pressure MOVPE system using hydrogen as carrier gas and standard precursors (arsine (AsH<sub>3</sub>), phosphine (PH<sub>3</sub>), trimethylindium (TMI), trimethylgallium (TMGa) and trimethylaluminium (TMAI)). Our growth conditions lead to an InGaAs and an InAlAs growth rate of around 1.8 ML/s for the active region.

The sample is grown on a low-doped ( $n \approx 10^{17} \text{ cm}^{-3}$ ) InP substrate. The active region contains 50 repeats of the following 4-well active region+injector structure (beginning with the injection barrier, layer thicknesses in nm): **4.3**/1.7/**1.0**/5.3/**1.2**/5.2/**1.2**/4.4/**2.5**/3.1/**1.7**/2.9/**1.6**/2.7/**1.8**/2.6/**2.1**/2.6/**2.4**/2.4 where bold numbers refer to Al<sub>0.52</sub>In<sub>0.48</sub>As barriers, roman type to In<sub>0.53</sub>Ga<sub>0.47</sub>As wells, and the underlined layers are *n*-doped to  $1 \times 10^{17} \text{ cm}^{-3}$ . The stack of active regions+injectors is sandwiched between top and bottom 0.5- $\mu\text{m}$ -thick *n*-doped  $5 \times 10^{16} \text{ cm}^{-3}$  InGaAs layer. The growth is then followed by a 3.35- $\mu\text{m}$ -thick InP top cladding layers (2.5  $\mu\text{m}$  *n*-doped  $5 \times 10^{16} \text{ cm}^{-3}$  and 0.85- $\mu\text{m}$  *n*-doped  $5 \times 10^{18} \text{ cm}^{-3}$ ) and finally an InGaAs 0.1- $\mu\text{m}$ -thick contact layer (*n*-doped  $9 \times 10^{18}$ ).

Standard laser ridges (22  $\mu\text{m}$  wide, 1.5 mm long and 7.5  $\mu\text{m}$  deep) were defined using inductively coupled plasma (ICP) etching. The whole sample was then passivated with a 700 nm-thick SiO<sub>2</sub> layer, which was etched on top of the laser ridges to allow electrical contacts. The same layer was also shaped - using electron-beam lithography followed by reactive ion etching - into bent and/or tapered sub-wavelength gratings at the proper positions on the sample. A Ti/Au metallization (5/200 nm thick) was evaporated at tilted angles, to provide both the electrical contact on top of the laser ridges, and the SPP carrying layer. After polishing and back-contact deposition, the samples were cleaved and In-soldered onto copper blocks for characterizations.

## Appendix 2: Curvilinear Devices

Figure 4 shows an optical microscope image of our curved waveguide device. It is composed by two circular - in opposite directions- successive bends of 45 degrees. The waveguide is 40  $\mu\text{m}$  wide, and the radius of curvature of the two bends is  $\sim 100 \mu\text{m}$ . The geometry of the sub-wavelength grating is identical to the focusing devices presented in the main core text of the paper. For processing reasons we have fabricated an identical, spatially translated reference curved waveguide which is however kept without metallization layer.

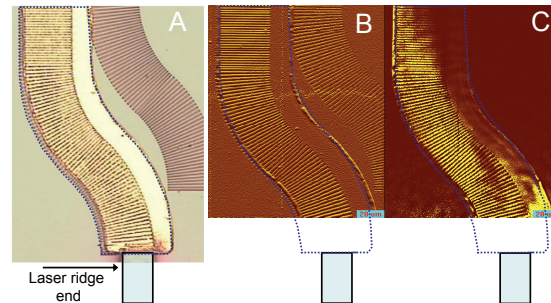


Fig. 4. Microscope (left), topographic (center) and NSOM (right) images of a typical curvilinear device.

The two right panels of Fig. 4 show the topographic image (center) and the s-NSOM image (right) measurements on the curved waveguide. The measurements show a clear guiding effect of our designer's SPPs in the circularly shaped waveguide. Note that the near-field signal is localized exclusively onto the metal coated sub-wavelength grating and it does not follow the non-patterned metallic region.

## Appendix 3: Estimate of SPP decay length

The plasmonic waveguides used in this first demonstration are 40  $\mu\text{m}$  wide in the Y direction: they can therefore support several transverse modes. Figure 5 shows an X-section of a 3D numerical simulation of the eigenmodes of such a waveguide: higher order modes are multi-lobed along the Y-axis.

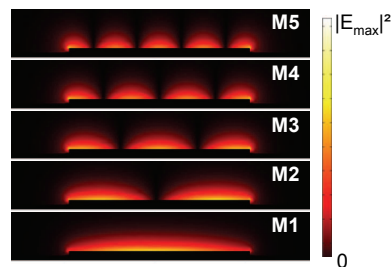


Fig. 5. Cross-section of the field-distribution (squared norm of the electric field) for 5 transverse modes sustained by the plasmonic waveguide.

If several modes are simultaneously present (multimode case), the value of the extracted decay length can depend on the chosen Y-section. We have therefore experimentally extracted the decay length value from a device with a uniform-width designer SPP waveguide and sustaining only one mode, as shown in Fig. 6.

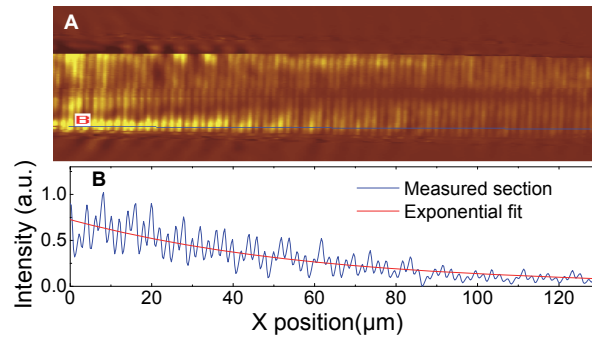


Fig. 6. (A) NSOM image of a straight plasmonic waveguide with only one transverse mode propagating. (B) 1D cross section of the NSOM signal, and exponential fit of the decay length

The NSOM measurements are performed in a "constant-width" section of a 40  $\mu\text{m}$ -wide designer's SPPs waveguide. This device and the one presented in Fig. 1 of the paper are located on the same semiconductor chip. As shown in Fig. 6, the propagating mode exhibits two lobes (second transverse mode according to Fig. 5). Assuming that one transverse mode only is propagating along the plasmonic waveguide, we extract a decay length of  $\sim 60 \mu\text{m}$ . Our goal here is to provide a lower limit for the propagation losses for comparison with existing works (tapered transmission lines, for instance).

### Acknowledgments

We acknowledge financial support from the French National Research Agency (ANR-07-NANO-039 "NanoFtir" and ANR-09-NANO-020 "Gospel"), the RTRA project "PHLARE", and from the Centre de Compétences Nanosciences Ile-de-France (PSTS). The device fabrication has been performed at the nano-center CTU-IEF-Minerve, which was partially funded by the Conseil Général de l'Essonne.